Suitable photo-resists for two-photon polymerization using femtosecond fiber lasers

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Direct laser writing (DLW) based two-photon polymerization [11], being a true 3D maskless lithography, with reproducible even sub 100 nm resolution [12], has then recently gained increasing attention in areas such as optics, biology and electronics [13–20]. A large number of applications have been reported for DLW TPP, ranging from photonic crystals, to metamaterials, plasmonics, micromachines, microfluidics, micro-optics and 3D scaffolds [21,22].

DLW-TPP technique consists into focusing a pulsed near infrared (NIR) laser beam into a photopolymer, made by a proper mixture of a photo-initiator and a monomer, through a high numerical aperture (NA) microscope objective, leading to multiphoton absorption only at the focal volume. The simultaneous absorption of two-photons creates radicals starting from the photo-initiator, triggering the monomer for cross-linking only in the focal volume, without affecting the outer resin. Thereby, moving the sample in 3D with respect to the beam or vice-verse allows the fabrication of the 3D micro-nano structures with, in principle, no limitations in the complexity of the shape geometry.

Most experimental setups for TPP lithography rely on mode-locked Ti:sapphire lasers [14–20,25–37,39] with a repetition rate of 80 MHz and 100 fs pulse, that can tune the wavelength over a wide near-infrared (NIR) range, thus being compatible with most photo-initiators (PIs) used in UV photolithography. Unfortunately...
the cost for the Ti:sapphire system is relatively high, so there’s an increasing request for materials that could adapt to the emerging technology of the less expensive femtosecond fiber lasers [23,24] that have the constraint of working at a fixed NIR wavelength (usually 780 nm). Therefore, we standardized a new material which can efficiently undergo TPP using femtosecond fiber laser.

2. Method and materials

Our optical setup (Fig. 1a) is based on a mode-locked Er-doped fiber laser (FemtoFiber Pro NIR, Toptica) lasing at 780 nm, with a repetition rate of 80 MHz and a 100 fs pulse width. An acoustic optical modulator (AOM) is used to regulate the laser power at the sample plane. The beam passes through a telescope where it is expanded to overfill the back focal plane of a microscope objective. The beam is then directed toward the microscope objective after passing through a dichroic mirror (DM), which reflects most of the NIR beam and transmits in the visible spectral range.

A piezoelectric stage with a travel range of 300 μm in the x, y and z coordinates is interfaced with a computer and driven by a custom written LabVIEW software. This program transmits the data, that is a point by point structure, and controls the movement of the piezo stage. A 60× dry objective with a 0.7 NA is used to focus the incoming beam into the pre-polymer. The objective is equipped with a correction collar that is used to minimize the spherical aberration. A LED light illumination helps to monitor in real time the beam alignment, focusing and fabrication process; the sample image is collected by a CCD camera. A short wave pass filter cuts the laser excitation on the camera.

To overcome the limitation set by the fixed NIR wavelength, we have tested different monomers and photo initiators with an absorption spectrum peaked around 400 nm (Fig. 2), thus compatible with our setup. In particular we selected a acrylic monomer with the following characteristics: simple preparation by drop casting, soluble in common solvents and inert towards aggressive ones, high cross-linking to resist swelling, stable at high temperature, low shrinkage, good mechanical properties, high transparency in the visible when polymerized, high optical quality and rapid polymerization. Especially polyfunctional acrylate of Bisphenol A ethoxylate diacrylate [25] has shown high photosensitivity, high refractive index, low shrinkage, thermal stability and good adhesion in the polymeric state for the optical, surface and mechanical properties.

Among the photo initiators, we selected isopropyl thioxanthone (ITX, Sigma–Aldrich), 7-diethylamino-3-thenylcoumarin (DETC, Exciton, USA), and 4,4”-bis(diethylamino)benzophenone (BDEB, Sigma), since their absorption spectra match well with the laser wavelength at 780 nm. Moreover these photo initiators grant high radical generation, reactivity and high solubility in acrylic monomers, also leading to an improvement in terms of resolution how has been recently shown [26,27].

Directly available monomer Bisphenol A ethoxylate diacrylate (BPA-EDA, Sigma–Aldrich) and the photoinitiators ITX, DETC and BDEB were used without further purifications. Monomer and the different PIs were mixed in the weight percentage ratio (98.5:1.5 for ITX; 99.75:0.25 for DETC and BDEB) as described in [26]. The material was kept under 30°C with stirring for 1 h to complete the dissolution of the photoinitiator into the monomer. The refractive index of the not exposed material is 1.54 and the exposed...
resists is around 1.59 [28]. A drop was then transferred into a cover slip (Fig. 1b) and placed on the xyz piezo with a holder.

Fabrication was performed following the scheme of single shell point by point exposure [29] that reduces fabrication time. Also, it allows having a self-smoothening [30] effect during the washing process of the unexposed part.

With this patterning strategy, structures such as asymmetric beads, micro-prisms, micro-spherical lenses and micro-cones were created. The exposure time for a single voxel was 10 ms and was optimized to have the shell thickness induced only by the voxels axial resolution and the lateral overlapping of 300 nm. After the exposure, the material is developed with a rinse in methanol and isopropanol for a few seconds. The developed structures are then exposed with UV to complete the polymerization of the resin inside the inner volume.

We note that the whole process is very simple and it doesn’t require additional pre- and/or post-processes as with other photo-curable resists in literature [12,18–20,31–36] (e.g. SU 8, NOA63, Nopcocure 800, hybrid sol–gel).

3. Characterization

The developed micro-structures were sputtered with 20 nm of gold for SEM analysis. The fabricated structures (Fig. 3a) prove the reliability of the proposed materials for fabrication of micro structures in terms of their size, geometrical shape, curvature, surface quality. They have also good adhesion property and low shrinkage after development.

In order to evaluate and compare the cross linking thresholds, we fabricated a micro-prisms structure with increasing power of the pulsed laser for the three different PIs (Fig. 3b). When exposed to the focused laser beam, the PI starts the polymerization with a minimum average-power threshold of around 1 mW. If we increase the optical power by a few mW, the polymerized structures achieve a good 3D mechanical stability, even with only the external surface exposed. We can see that BDEB has a higher cross linking threshold respect to ITX, but the latter needs a higher power to achieve enough mechanical stability with just a single-shell.

The achievable mechanical stability is further demonstrated with the fabrication of asymmetric bead structures, as seen from the Fig. 3a (top left), that find applications in optical tweezers (OTs)-based plasmonics [37]. This structure shows the potential of TPP to create arbitrary 3D geometries. For the optical trapping, the main body has three ellipsoidal bodies that act like handles, which are supported by a thin structure. The proposed material grants transparency and its good mechanical properties are evident from the thin structure which is able to withstand the relatively large top ellipsoid along with a protruding arm. For the plasmonic application, a metal nanocone, which acts as plasmonic probe, will be then fabricated by Electron Beam Induced Deposition [8] at the tip of the long arm.

Further, micro-optical components have been fabricated at the end facets of optical fibers. A miniaturized optical tweezers [38] based on optical fibers was recently proposed by exploiting beam deflection due to the total internal reflection (TIR) at the interface between fibers and the surrounding medium. At the point where the deflected beams converge together, there is the trapping point. To implement these deflecting structures by using TPP, we fabricated micro-prisms (Fig. 3a (top right)) with very smooth surface on the output facet of a fiber. On integrating this optical trapping function into a micro-fluidics chip, it has been demonstrated the trapping and spectroscopic analysis of single cells [20].

Similarly to the Ref. [39] we also demonstrate the fabrication of highly surface smoothened micro-lens Fig. 3a (bottom left) with sizes on the order of tens to hundreds of micrometers for fiber-based imaging.

Additionally, high aspect ratio micro-cones (Fig. 3a (bottom right)) were fabricated for plasmonic terahertz applications [40].

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Fig. 2. Absorption spectra of monomer BPA-EDA in ITX, DETC and BDEB photoinitiators.

Fig. 3. (a) SEM images of TPP fabrication with single shell exposure. (b) SEM images of prisms fabricated with three different photo-initiators (top to bottom) at increasing power (left to right).

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At last, we have fabricated micro-parabolic reflectors (Fig. 4a and b) on top of multimode (MM) fibers to increase their numerical aperture (NA). This micro-fabricated optics [41] can be used in endoscopy through fiber imaging based on single MM fiber. The optical beam emerging from the fiber is reflected by the lateral parabolic surface due to the TIR. Fig. 4a shows the optical image of the micro-parabolic reflector as a beam deflector on a MM fiber. Their SEM images in the Fig. 4b clearly shows the smoothness of the lateral surfaces.

All these structures demonstrate the versatility of TPP with our proposed material for the fabrication of structures of both good optical and mechanical properties by using femtosecond fiber lasers.

4. Conclusions

We have proposed efficient and reliable materials for TPP using femtosecond fiber laser. The proposed PIs, due to their single photon absorption peaked around 400 nm, generate radicals efficiently for TPP at the fixed wavelength of the femtosecond fiber laser. Optimized materials have simple processing with adequate optical and mechanical properties by using femtosecond fiber lasers.

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References